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CONFIRMATION NO. 9929

SERIAL NUMBER 10/588,698	FILING or 371(c) DATE 08/08/2006 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. 039262-0156	
APPLICANTS Tadahiro Ohmi, Miyagi, JAPAN; Tetsuya Goto, Miyagi, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/01513 02/02/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-032607 02/09/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ** 04/09/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /CARIDAD Acknowledged EVERHART/ Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 6	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 3
ADDRESS FOLEY AND LARDNER LLP SUITE 500 3000 K STREET NW WASHINGTON, DC 20007 UNITED STATES					
TITLE Method of manufacturing a semiconductor device and method of etching an insulating film					
FILING FEE RECEIVED 575	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		